

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Confirmation No.: 4391

Toshinori OTA

Date: July 23, 2010

Serial No.: 10/555,855

Group Art Unit: 1795

Filed: November 7, 2005

Examiner: Golam MOWLA

For: THERMOELECTRIC SEMICONDUCTOR MATERIAL, THERMOELECTRIC  
SEMICONDUCTOR ELEMENT THEREFROM, THERMOELECTRIC  
MODULE INCLUDING THERMOELECTRIC SEMICONDUCTOR ELEMENT  
AND PROCESS FOR PRODUCING THESE

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**VIA EFS-WEB**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

**INFORMATION DISCLOSURE STATEMENT**

Sir:

Submitted herewith is a Form 1449 for consideration by the Examiner.

Applicants note that there was a typographical error in the Information Disclosure Statement filed with the application on August 29, 2006. Reference JP2001-053344 should have a publication of February 2001. Reference JP2001-160633 should have a publication of June 2001. Reference "JP2001-34587" should read "JP2001-345487". An annotated copy of the Form 1449 is enclosed.

No fee is deemed necessary in connection with the filing of the subject Information Disclosure Statement. However, in the event a fee is required, or if any fee due during the pendency

of this application is not paid, the Patent and Trademark Office is authorized to charge the underpayment to Deposit Account No. 15-0700.

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SUBMITTED ELECTRONICALLY  
THROUGH THE UNITED STATES  
PATENT AND TRADEMARK OFFICE  
EFS FILING SYSTEM ON JULY 23,  
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Respectfully submitted,



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RCF/mw  
Enc.